

Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only

EFS ID: 15333
Application ID: 10063869
Title of Invention: INSPECTION METHOD AND
INSPECTION APPARATUS FOR
SEMICONDUCTOR CIRCUIT
First Named Inventor: Chihiro Araki
Domestic/Foreign Application: Domestic Application
Filing Date: null
Effective Receipt Date: 2002-05-21
Submission Type: Utility Patent Filing
Filing Type: new-utility
Confirmation Number: 0
Attorney Docket Number: SIMTEK6349
Digital Certificate Holder: cn=Ernest A. Beutler, ou=Registered Attorneys, ou=Patent and
Trademark Office, ou=Department of Commerce, o=U.S.
Government, c=US
Certificate Message Digest: zToMcv96EnQffnvpnvXDLg==
Total Fees Authorized: \$780.0

Payment Category: CC - Credit Card
Credit Card Number: *****2005
Expiration Date: 12312002
Card Holder Name: Ernest A Beutler Attorne
RAM User ID: EFSPROD
RAM Accounting Date: 2002-05-21
RAM Sequence Number: 455743
RAM Payment Status: RAM success
Postal Code: 92660

APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: SIMTEK6349

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: INSPECTION METHOD AND INSPECTION APPARATUS FOR
SEMICONDUCTOR CIRCUIT

Customer Number Attorney: 025776



Customer Number Correspondence Address: 025776



Foreign Priority:

2001-161739

JP 2001-05-30

Priority Claimed

INVENTOR(s):

Primary Citizenship: JAPAN

Given Name: Chihiro

Family Name: Araki

Residence City: Shuuchi-gun

Residence Country: JP

Address: c/o 1450-6 Mori

Shuuchi-gun , JP